

Notice of References Cited	Application/Control No. 10/809,929		Applicant(s)/Patent Under Reexamination NAKAMURA ET AL.	
	Examiner David S. Kim		Art Unit 2613	Page 1 of 1

U.S. PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
*	A	US-2003/0099013 A1	05-2003	Su et al.	359/124
*	B	US-2005/0013615 A1	01-2005	Matsuda, Osamu	398/083
*	C	US-2005/0041975 A1	02-2005	Nakamura et al.	398/085
*	D	US-2007/0116468 A1	05-2007	Jl et al.	398/079
	E	US-			
	F	US-			
	G	US-			
	H	US-			
	I	US-			
	J	US-			
	K	US-			
	L	US-			
	M	US-			

FOREIGN PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification
	N					
	O					
	P					
	Q					
	R					
	S					
	T					

NON-PATENT DOCUMENTS

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
	U	
	V	
	W	
	X	

*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)
Dates in MM-YYYY format are publication dates. Classifications may be US or foreign.